



# Corrosion-resistant Mg-based multilayer coatings for sources > 25 nm

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*Lawrence Livermore National Laboratory*

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# Technical contributors



- Jeff C. Robinson, Monica Fernández-Perea, Christopher C. Walton, Sherry L. Baker, Jennifer Alameda (*LLNL*)
- Eric M. Gullikson, Julia Meyer-Ilse (*CXRO/LBNL*)
- Luis Rodríguez-De Marcos, Jose A. Méndez, Manuela Vidal-Dasilva, Juan I. Larruquert (*Instituto de Óptica, Consejo Superior de Investigaciones Científicas (CSIC), Madrid, Spain*)

# Overview



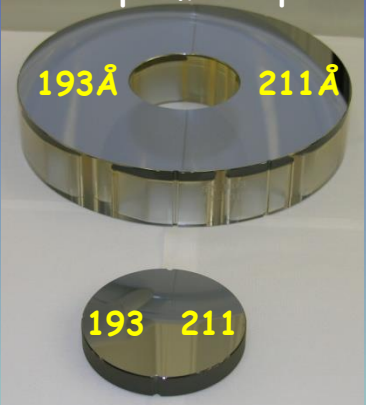
- Motivation: applications at  $\lambda = 25 - 80$  nm that benefit from Mg/SiC multilayers
- Design and experimental performance of Mg/SiC multilayers
- Origins, propagation mechanisms and impact of Mg/SiC corrosion
- Al-Mg corrosion barriers for Mg/SiC
  - Al-Mg spontaneous intermixing and amorphization
  - Lifetime properties and performance optimization of Mg/SiC with Al-Mg corrosion barriers

# Multilayer coatings with stability > 10 years are needed for space-borne EUV solar physics telescopes

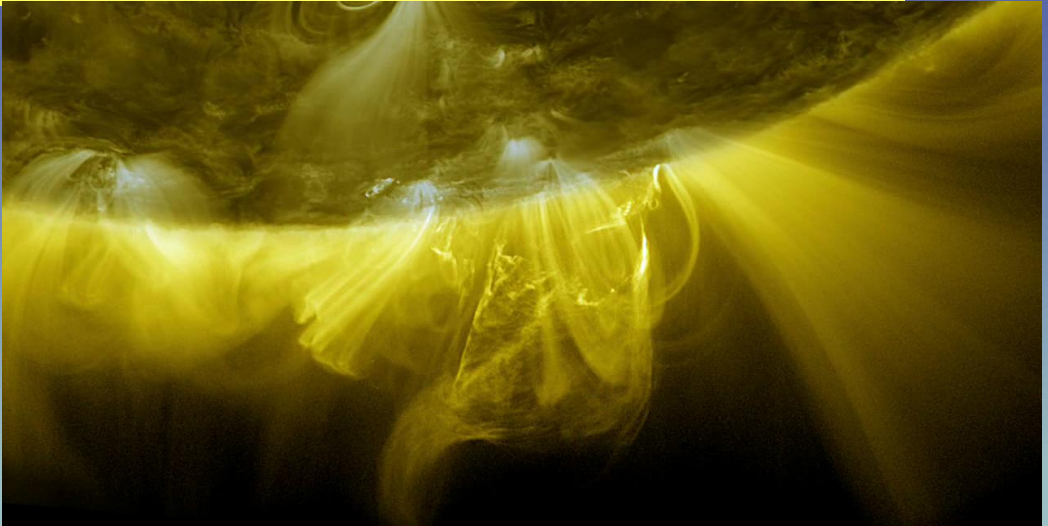


**NASA's Solar Dynamics Observatory (SDO). Launched: February 11, 2010.**

Multilayer-coated SDO telescope mirror pair

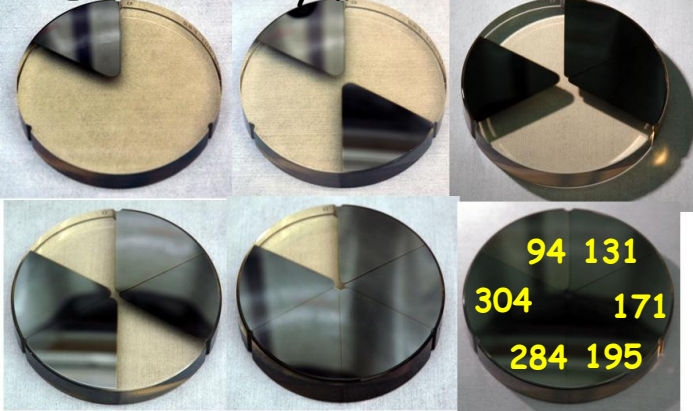


4 telescopes  
 2 wavelengths per telescope  
 7 EUV wavelengths,  
 94 - 335 Å.  
 1 arcsec resolution  
 41x41 arcmin FOV  
 12 sec cadence  
 2 Tbytes / day



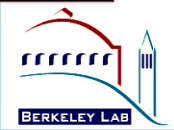
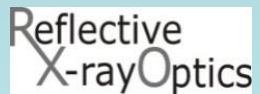
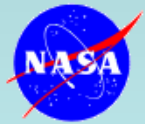
**NASA/NOAA's GOES-R, -S, -T, -U space weather satellites. Launch: 2016 - 2020**

GOES-R secondary mirror



6 EUV wavelengths  
 (94 - 304 Å) on a  
 single telescope.

Soufli, Proc. SPIE 59010M (2005)  
 Soufli, Appl. Opt. 46, 3156-3163 (2007)  
 Boerner, Solar Physics 275, 41-66 (2012)  
 Lemen, Solar Physics 275, 17-40 (2012)  
 Soufli, Proc. SPIE 8443R (2012)  
 Martinez-Galarce, Opt. Eng. 52, 095102 (2013).

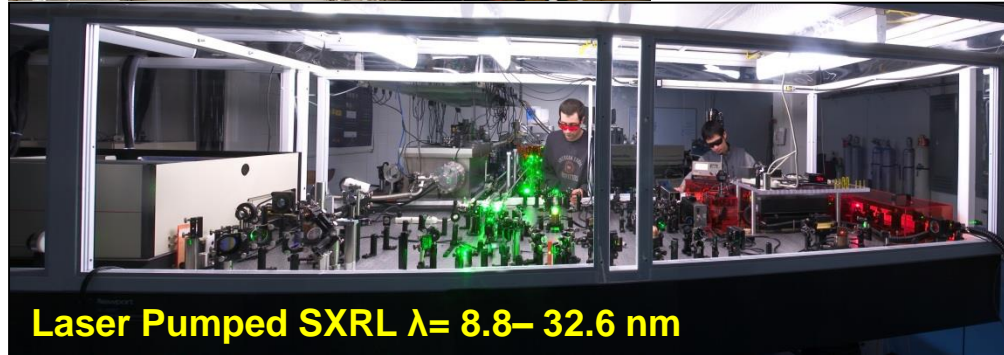
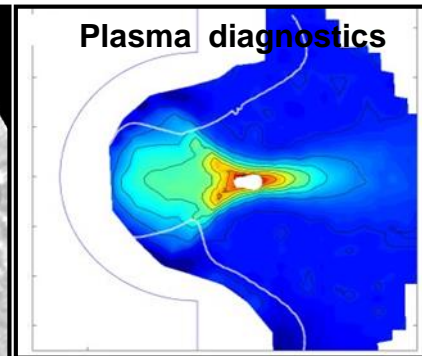
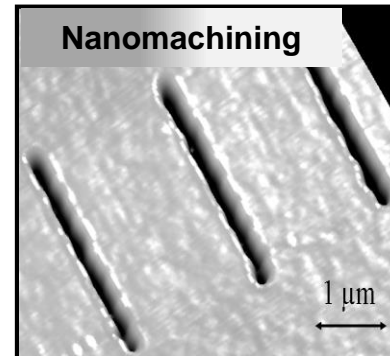


# Compact plasma-based EUV laser sources and applications need efficient multilayer coatings

Discharge Pumped SXRL  $\lambda=46.9$  nm

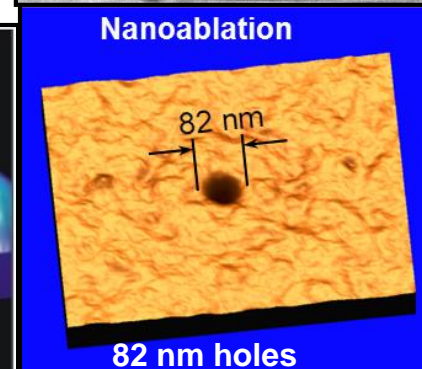
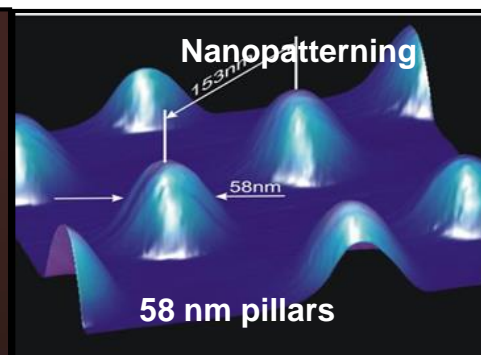
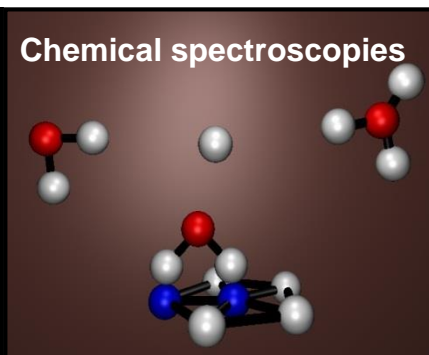
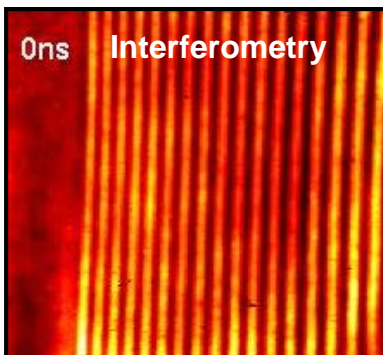
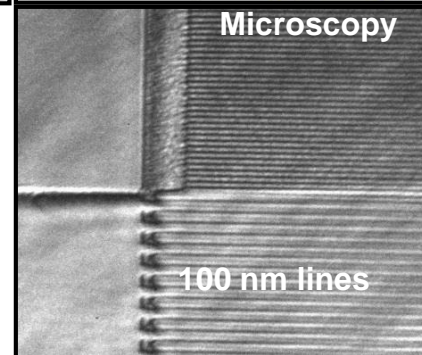


Courtesy: Profs. Jorge Rocca and Carmen Menoni, Colorado State University



Laser Pumped SXRL  $\lambda= 8.8- 32.6$  nm

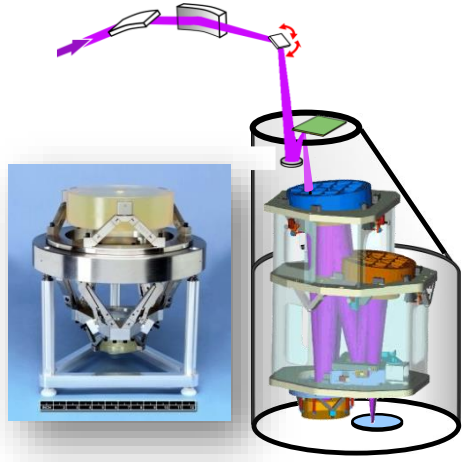
- High pulse energy ( $\mu\text{J}-\text{mJ}$ )
- High monochromaticity ( $\lambda/\Delta\lambda < 10^{-4}$ )
- High peak spectral brightness



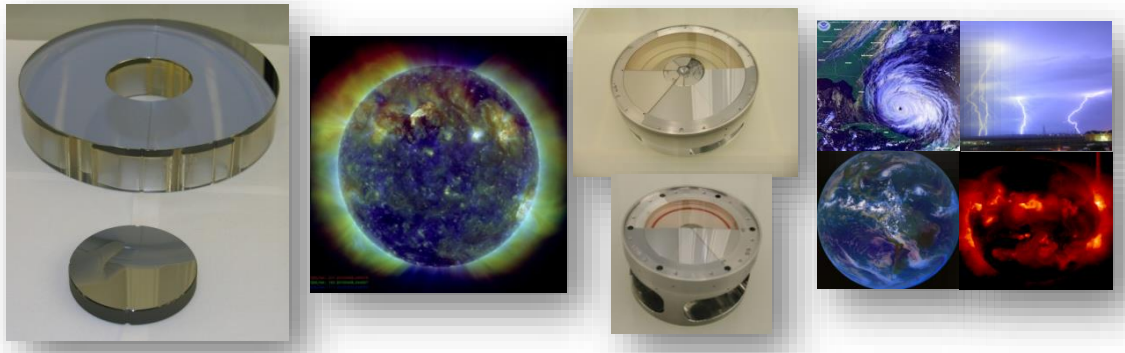
# Our group at LLNL has participated in the development of short-wavelength optics for various applications



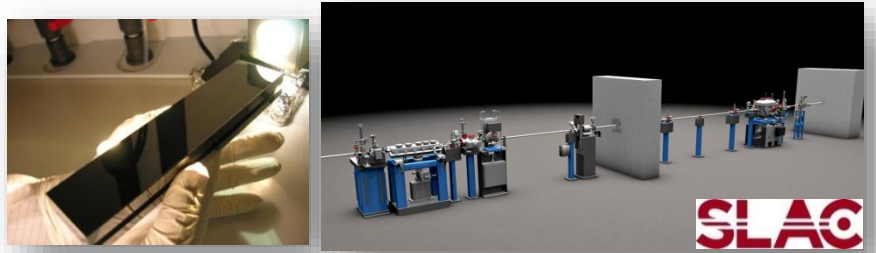
EUV Lithography:  
ETS1, ETS2, MET2, MET5



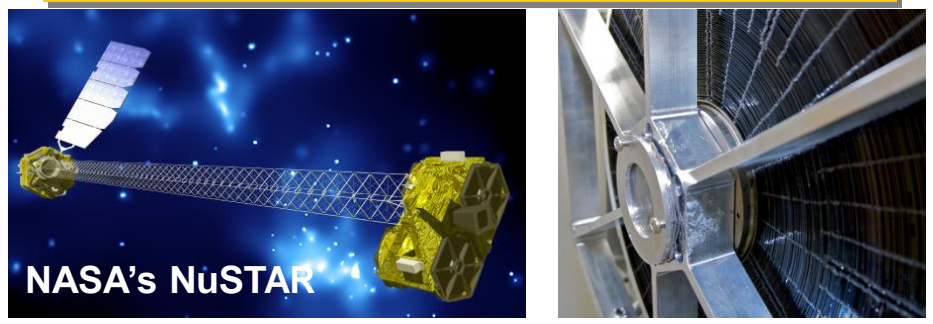
EUV solar missions and laser sources



X-ray optics for the LCLS free-electron laser



Hard x-ray /gamma-ray astrophysics,  
radiation detection, target diagnostics



# LLNL facilities for thin film deposition and characterization



## DC- and RF-magnetron sputtering deposition systems



R&D  
100

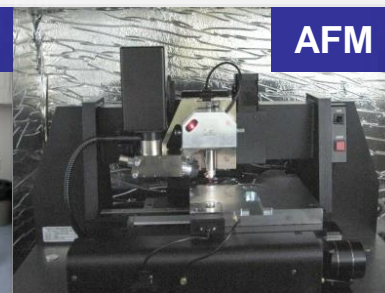


R&D  
100

## Precision surface metrology



ZYGO



AFM



SEM

Also (not pictured):

- Contact profilometers
- Thin film stress measurement apparatus
- Full-aperture interferometers

## Custom cleaning facility for optical substrates



## X-Ray Diffractometer

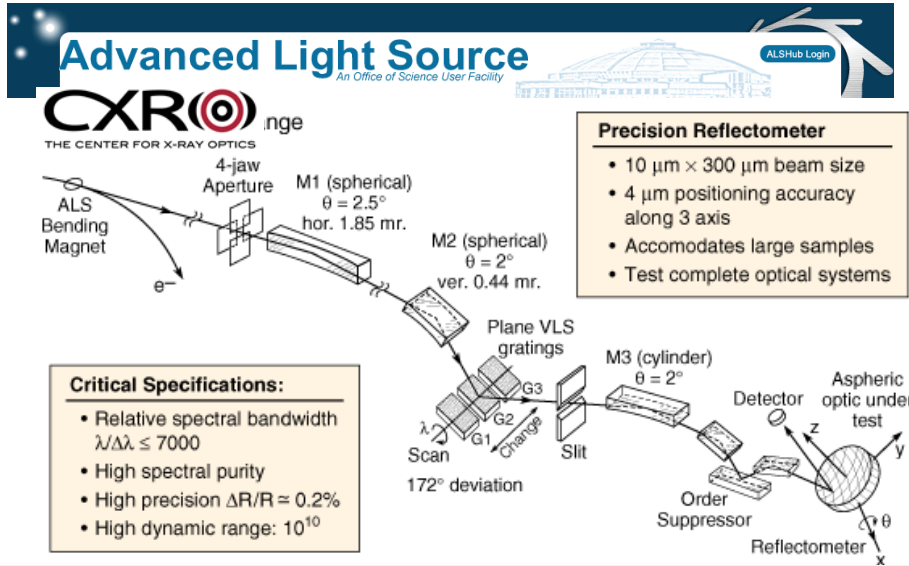


affli

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# Light sources employed for at-wavelength testing of multilayer optics in this presentation



INSTITUTO DE OPTICA

Castellano | English



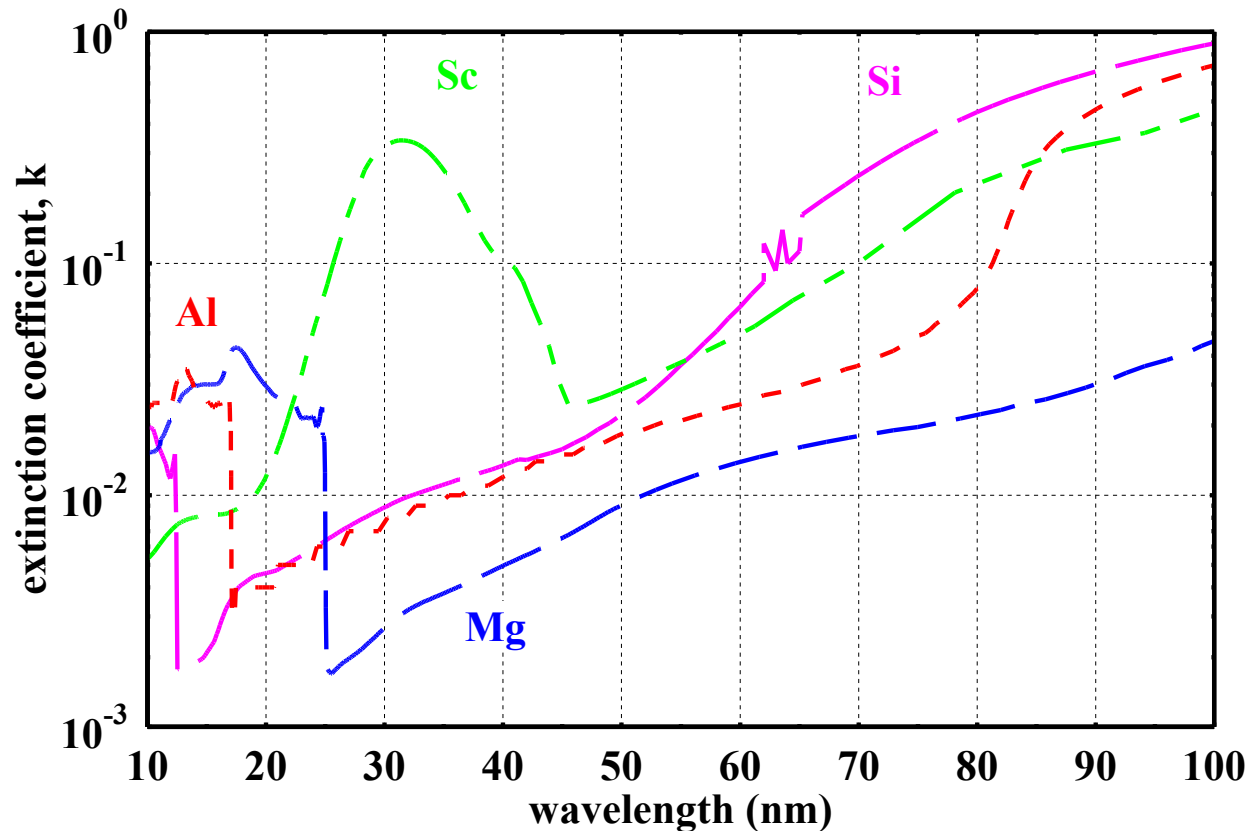
**GOLD facility,  $\lambda = 50-200 \text{ nm}$**

**Calibration and standards ALS beamline 6.3.2**  
 **$\lambda = 1-90 \text{ nm}$**





# Mg exhibits low absorption in an extended wavelength range for $\lambda > 25$ nm (Mg $L_{2,3}$ edge)



## Refractive index = $n + i*k$

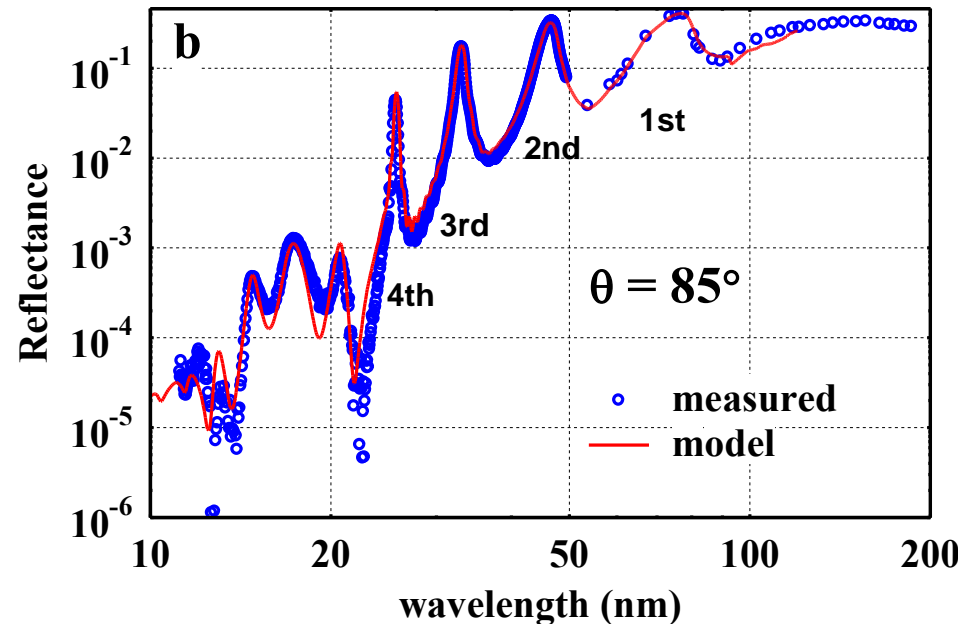
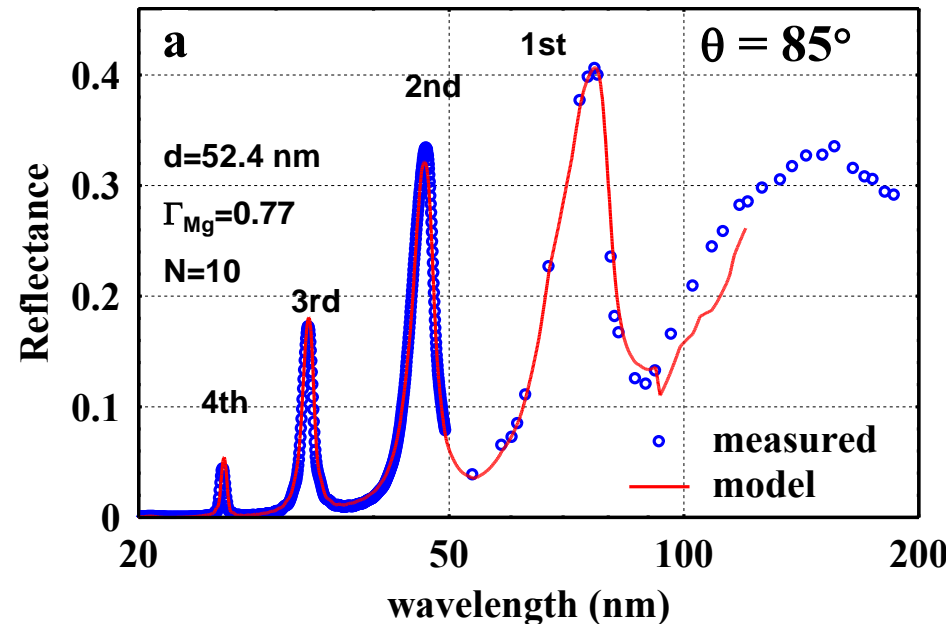
Extinction coefficient  $k$  values obtained from:

- 1. Mg:** M. Vidal-Dasilva, *et al*, J. Appl. Phys. 108, 063517 (2010).
- 2. Al:** E. Shiles, *et al*, Phys. Rev. B 22, 1612-1628 (1980), as compiled by E. D. Palik, *Handbook of optical constants of solids* (Academic Press, 1985).
- 3. Si:** R. Soufli and E. M. Gullikson, Appl. Opt. 36, 5499-5507 (1997). H. R. Philipp, J. Appl. Phys. 43, 2835-2839 (1972), compiled by E. D. Palik, *Handbook of optical constants of solids* (Academic Press, 1985).
- 4. Sc:** M. Fernández-Perea, *et al*, J. Opt. Soc. Am. A 23, 2880-2887 (2006).

# Mg/SiC achieves the highest narrowband peak reflectance at $\lambda = 76.9$ nm: $R = 40.6\%$ at near-normal incidence



## Standard Mg/SiC (no corrosion barriers)



☐ Measurements performed at:

- Beamline 6.3.2., Advanced Light Source, LBNL, for  $\lambda < 50$  nm
- GOLD facility, Instituto de Óptica, Madrid, Spain, for  $\lambda = 50$ -200 nm

☐ Model = IMD software by D. L. Windt, Computers in Physics 12, 360–370 (1998)

M. Fernández-Perea, R. Soufli, J. C. Robinson, L. Rodríguez-de Marcos, J. A. Mendez, J. I. Larruquert and E. M. Gullikson, "Triple-wavelength, narrowband Mg/SiC multilayers with corrosion barriers and high peak reflectance in the 25-80 nm wavelength region", *Optics Express* **20**, 24018-24029 (2012).

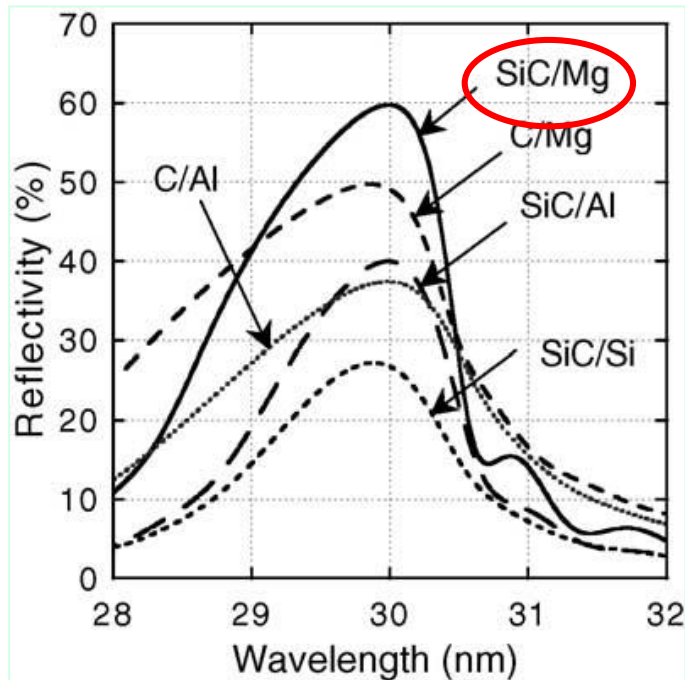
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# Mg/SiC is the best multilayer for the 25-80 nm wavelength region, except ...

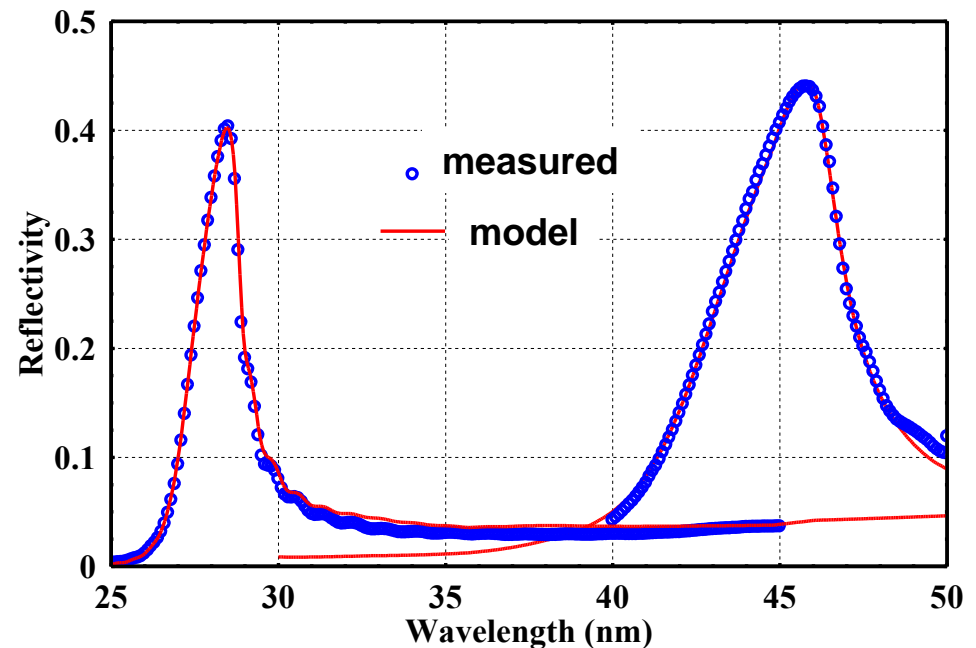
Mg/SiC exhibits a unique combination of high reflectivity, near-zero stress, thermal stability to  $\sim 350^\circ\text{C}$  and good spectral selectivity compared to other candidate multilayer pairs in the 25-80 nm region

Calculated ideal reflectivity (roughness=0) for different multilayers



H. Takenaka *et al.*, J. of El. Spectr. and Rel. Phen. **144-147**, 1047 (2005).

Mg/SiC deposited at LLNL, measured at ALS beamline 6.3.2

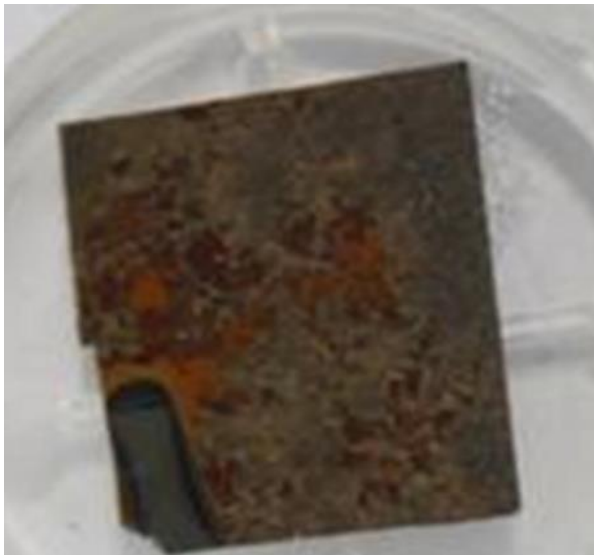


# ...atmospheric corrosion prevents Mg/SiC from being used in applications requiring long lifetime stability



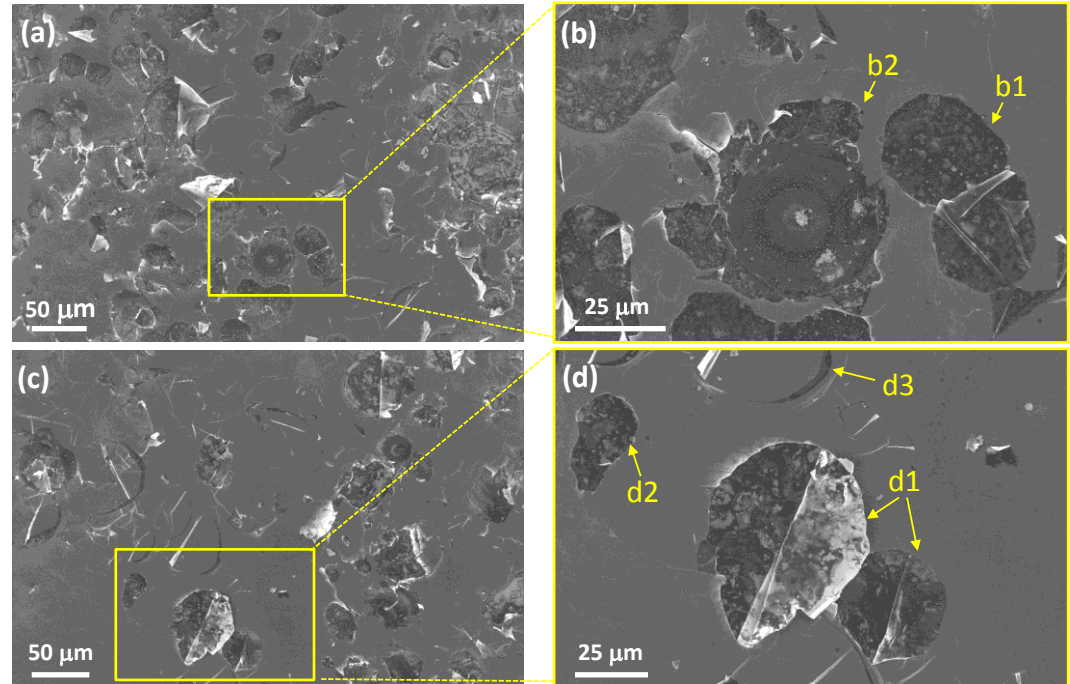
Corrosion has prevented Mg/SiC use in EUV solar telescopes, free-electron lasers, and HHG sources

**Mg/SiC with advanced corrosion aged for 4 years**



M. G. Pelizzo, A. J. Corso, P. Zuppella, P. Nicolosi, S. Fineschi, J. Seely, B. Kjornrattanawanich, and D. L. Windt, *Opt. Eng.* **51**, 023801 (2012).

**Top-surface SEM of Mg/SiC with advanced corrosion aged for 2.7 years**



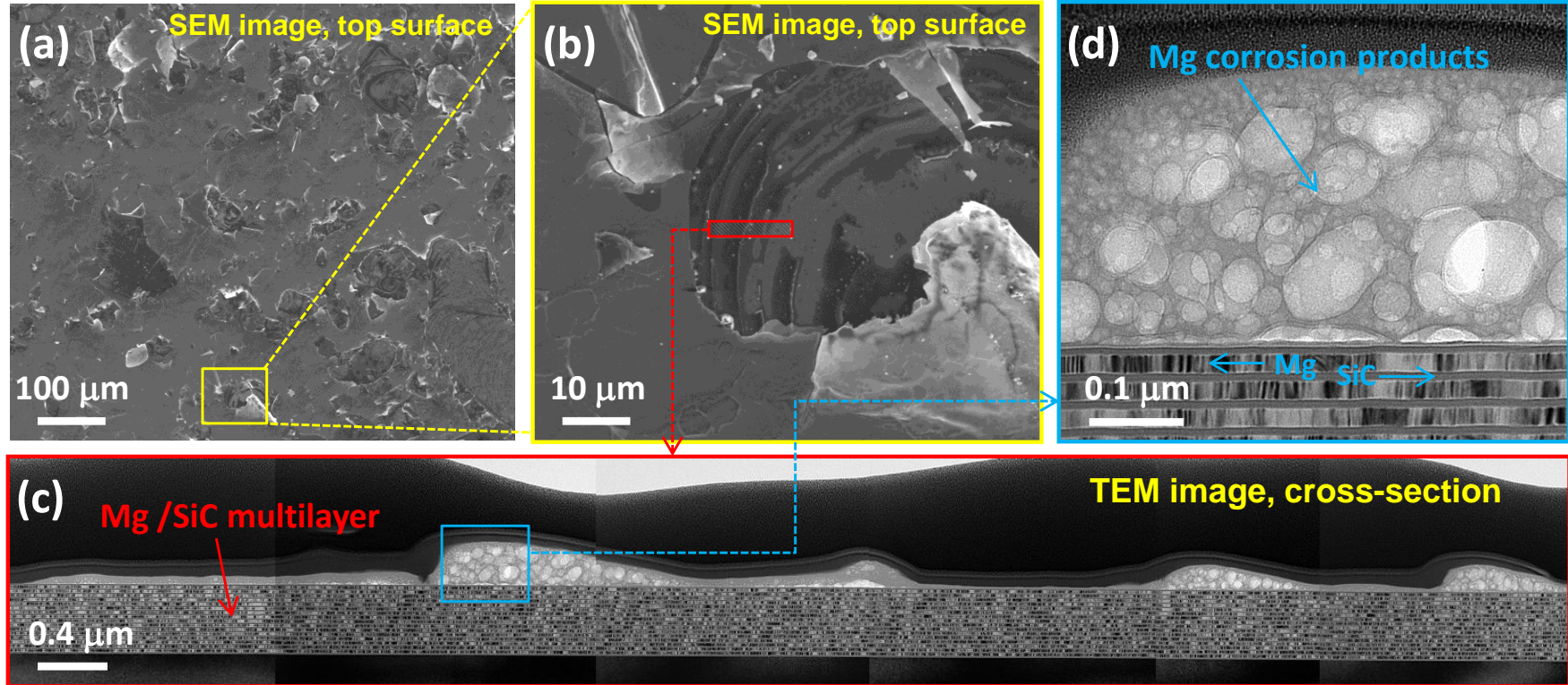
R. Soufli, M. Fernández-Perea, S. L. Baker, J. C. Robinson, J. Alameda, C. C. Walton, *App. Phys. Lett.* **101**, 043111 (2012).

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# Advanced corrosion exhibits eruptive effects due to formation and volume expansion of corrosion products



Mg/SiC with advanced, eruptive stages of corrosion aged for 3 years.  
4 top bilayers (out of 20) have been consumed and are missing



Binding energy (eV)	Orbital	Species
50.8	Mg 2p	MgO, Mg(OH) <sub>2</sub> , Mg(CO) <sub>3</sub>
532.8	O 1s	OH <sup>-</sup> , Mg(OH) <sub>2</sub>

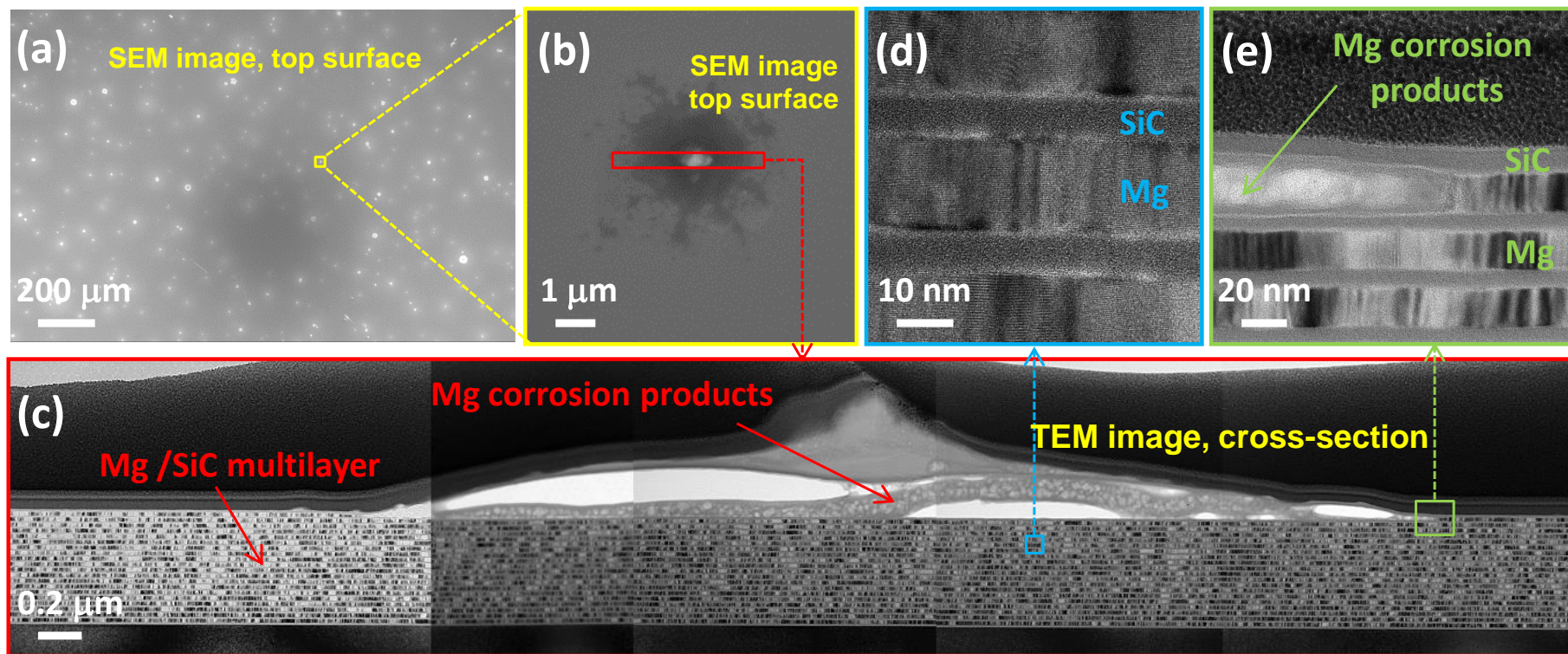
TEM and XPS analysis performed at EAG Labs, Sunnyvale, California

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# We have elucidated the origins and propagation mechanisms of corrosion in Mg/SiC multilayers



Atmospheric corrosion attacks Mg/SiC from the top surface via localized entry points such as pinholes and defects, inherent in sputtered thin films



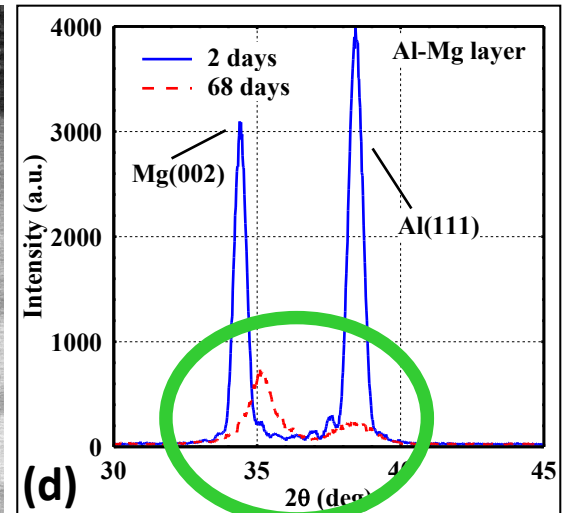
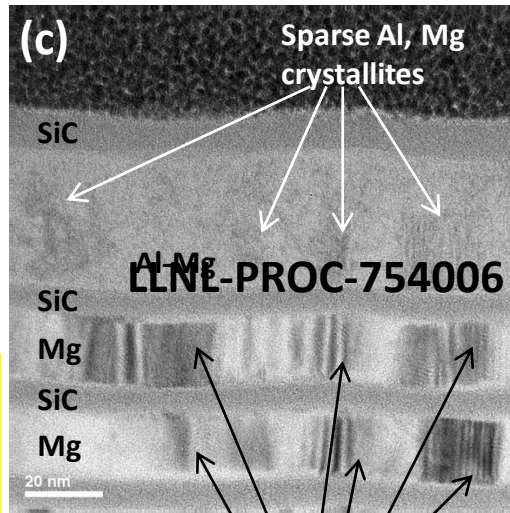
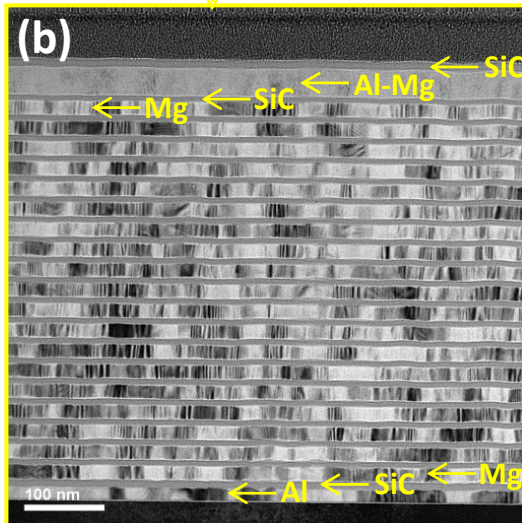
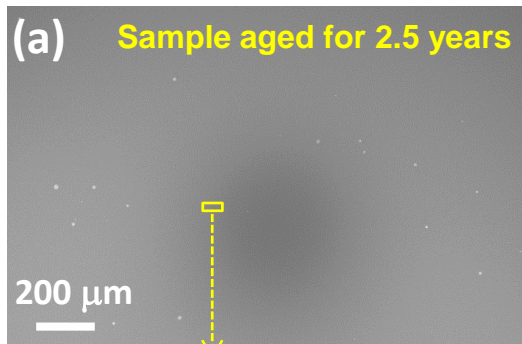
Mg/SiC aged for 3 years, with early, pre-eruptive stages of corrosion

# Al-Mg corrosion barrier structures for Mg/SiC multilayers



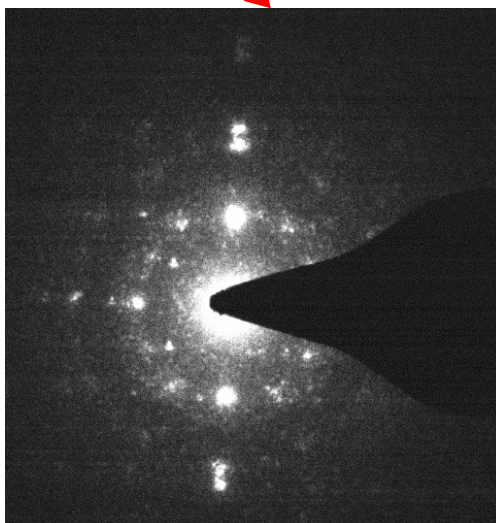
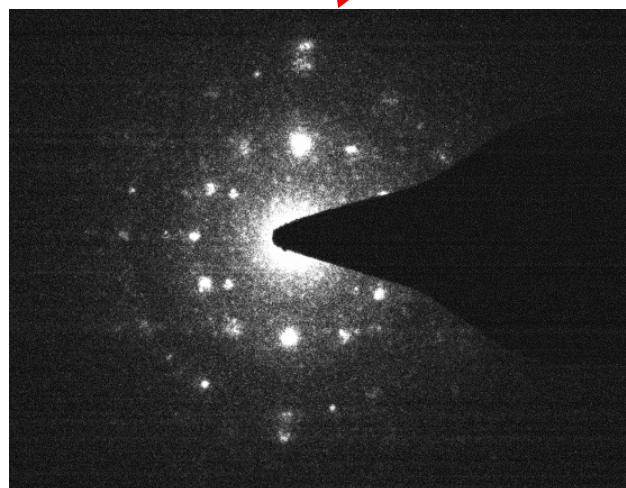
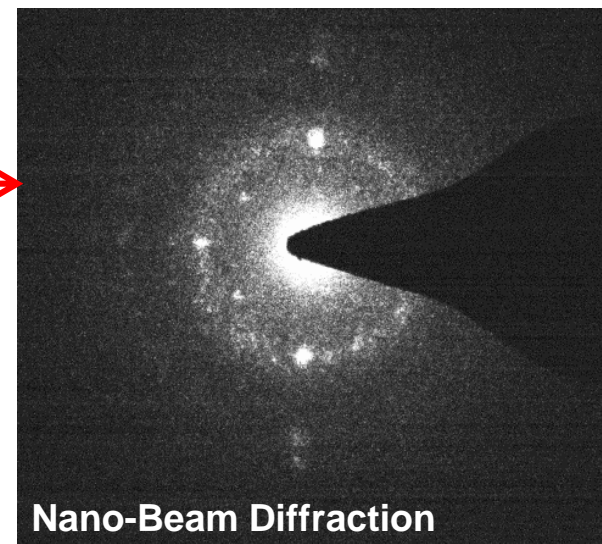
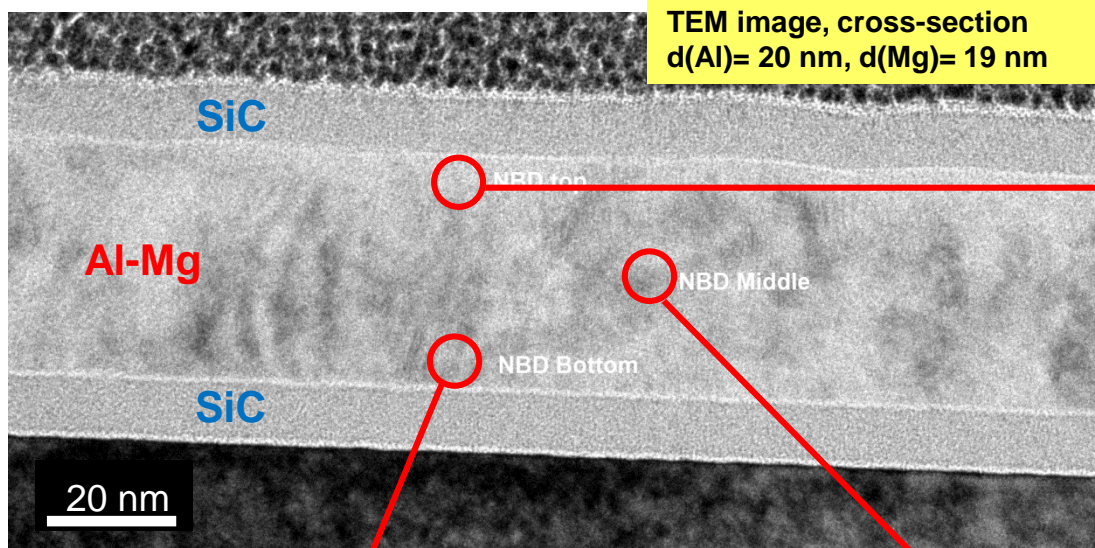
Polycrystalline Al (20 nm) and Mg (19 nm) layers spontaneously intermix to produce partially amorphous Al-Mg layer.

R. Soufli, M. Fernández-Perea, S. L. Baker, J. C. Robinson, J. Alameda, C. C. Walton, App. Phys. Lett. **101**, 043111 (2012).



(e)	Days after deposition	Bragg peak, 2θ (deg)	Lattice spacing (nm)	Crystallite size (nm)
Al(111)	2	38.44	0.23	15.13
"	68	38.41	0.23	4.57
Mg(002)	2	34.41	0.26	16.7
"	68	35.14	0.25	9.15

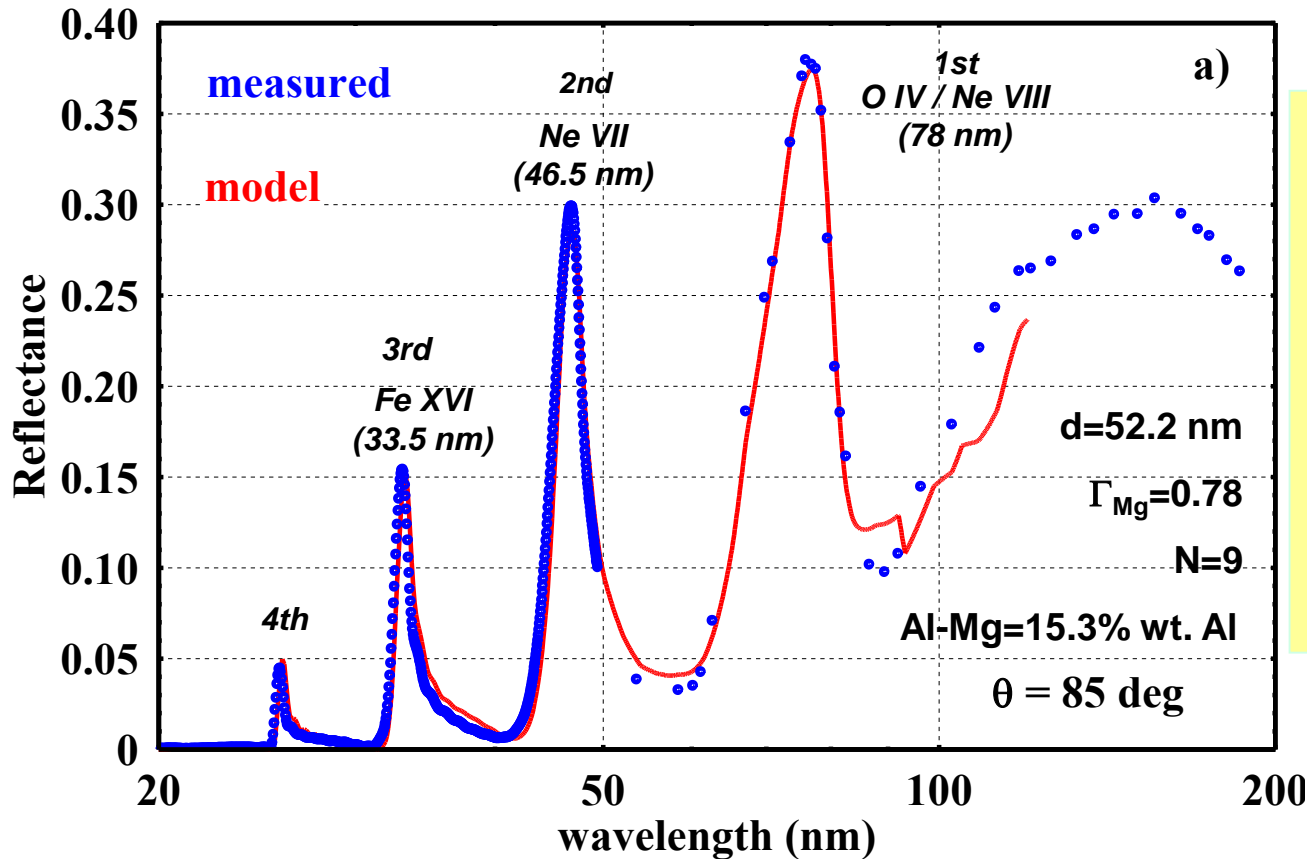
# We are investigating in detail the physics of the Al-Mg intermixing and amorphization process



▪ Intermixed region of Mg layer (bottom) exhibits higher degree of “crystallinity” than Al layer (top)



# Triple-wavelength Mg/SiC multilayers with corrosion barriers can be employed in EUV imaging or spectrometer instruments



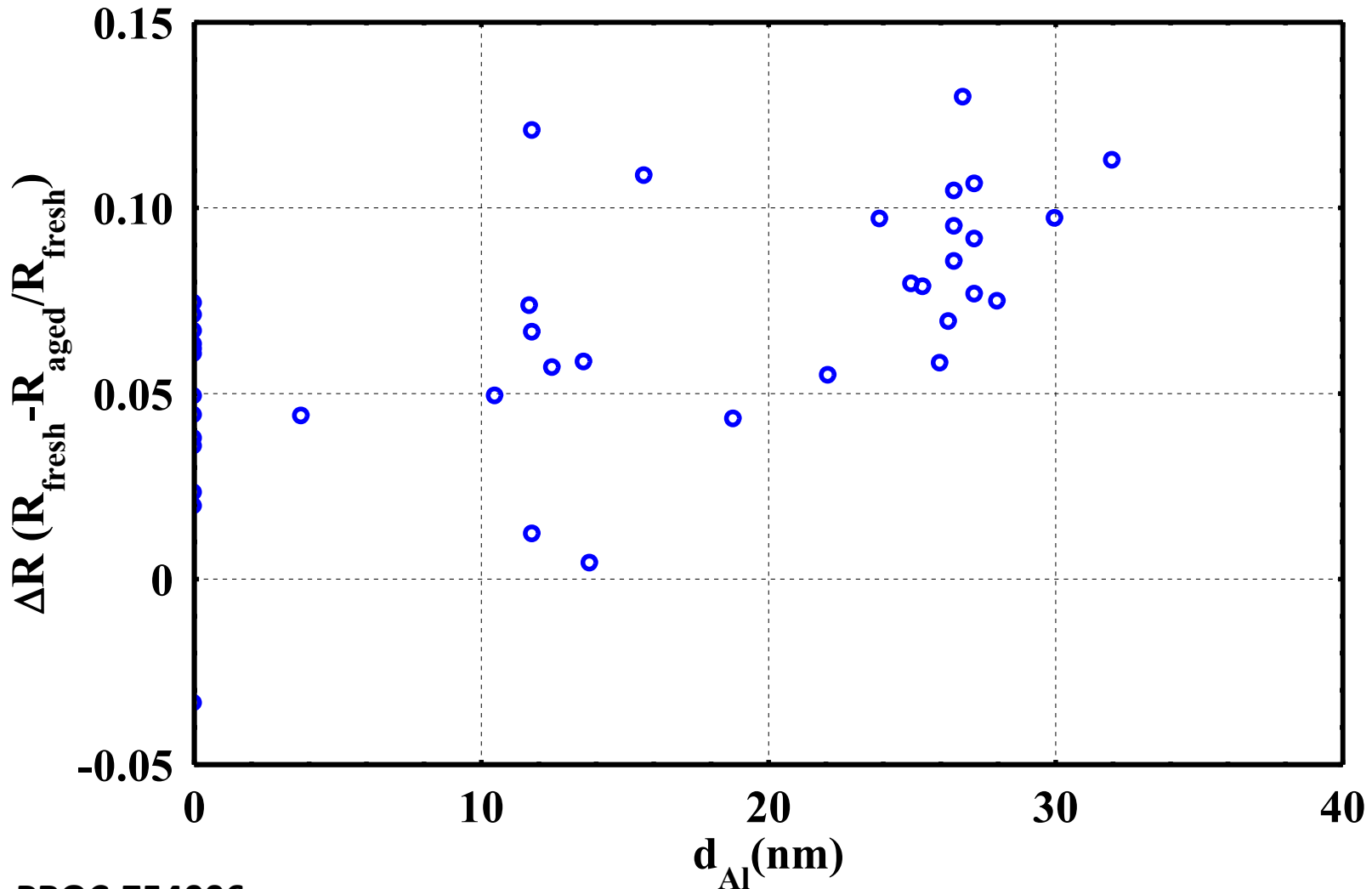
Refractive index values obtained from:

1. **Mg**: M. Vidal-Dasilva, *et al*, J. Appl. Phys. 108, 063517 (2010).
2. **SiC**: J. B. Kortright and D. L. Windt, Appl. Opt. 27, 2841-2846 (1988).
3. **Al**: E. Shiles, *et al*, Phys. Rev. B 22, 1612-1628 (1980), as compiled by E. D. Palik, *Handbook of optical constants of solids* (Academic Press, 1985).

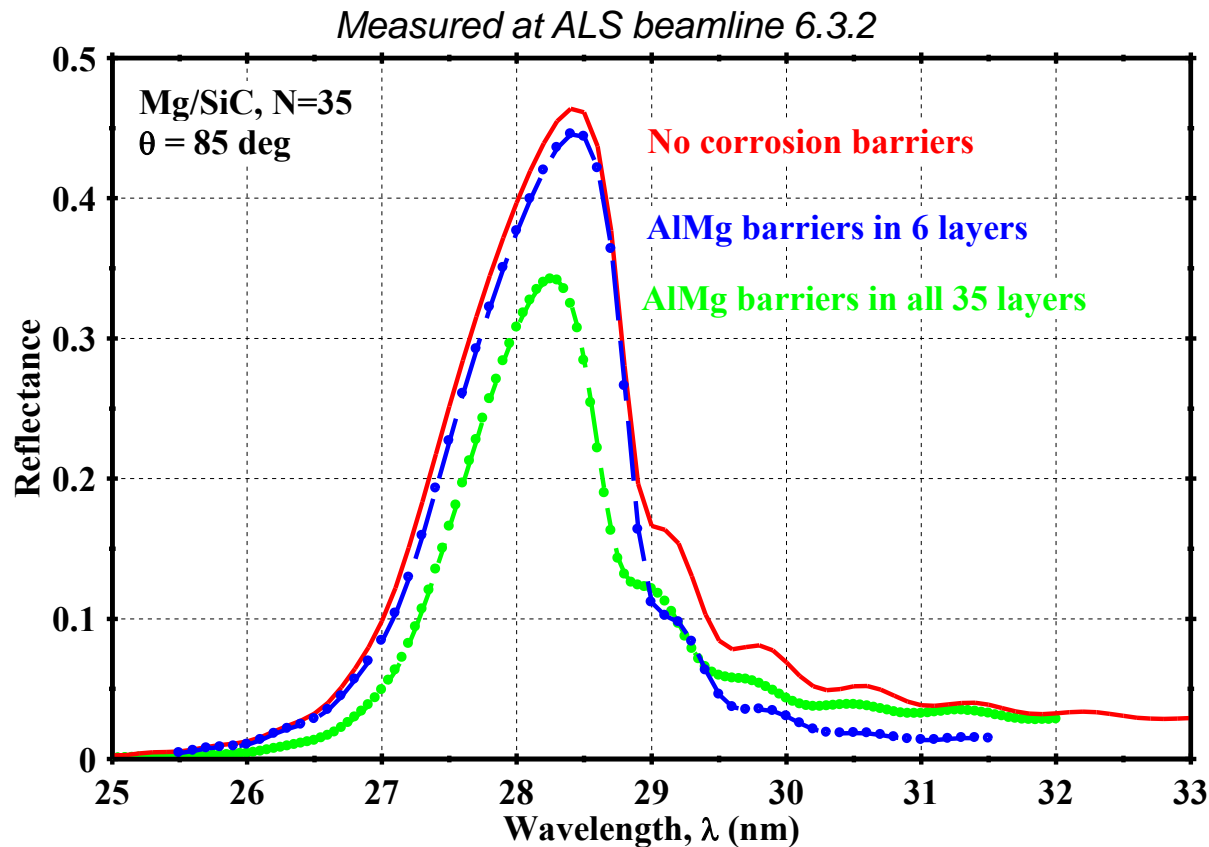
# Reflectance loss after 3 years of aging appears to increase with Al thickness



Mg/SiC samples reflecting at 28 and 46 nm, with and without Al-Mg corrosion barrier layers



# Performance optimization of Mg/SiC coatings with and without AlMg corrosion barriers



- Insertion of 6 barrier layers in a Mg/SiC stack of 35 layers has minimal impact in reflectance
- Significant reflectance can be achieved even with corrosion barriers in all 35 layers
- In addition to corrosion protection, AlMg barriers improve out-of-band suppression

# Summary



- Atmospheric corrosion has prevented the use of Mg/SiC multilayers in applications requiring good lifetime stability, such as EUV laser sources and solar physics
- We have developed Al-based barrier layers that dramatically reduce corrosion in Mg/SiC multilayers, while preserving high reflectance
- Corrosion barrier layers can be customized specifically for each multilayer design and environmental conditions
- Mg/SiC with Al-based corrosion barriers has been implemented in upcoming EUV solar physics missions
- Investigation of the physics of spontaneous intermixing and amorphization of sputtered Al and Mg layers is ongoing



# Funding acknowledgements

- Funding for the Mg/SiC corrosion barrier work was provided by the LLNL Laboratory Directed Research and Development program
- GOLD acknowledges financial support from the National Program for Space Research, Subdirección General de Proyectos de Investigación, Ministerio de Ciencia y Tecnología, project number AYA2010-22032
- Additional funding was provided by Lockheed Martin Corporation Internal Research and Development